

U.S. Department of Commerce, Patent and Trademark Office						Atty Docket No.		Serial No.	
						03848.0001 / 3034.1A		09/578,282	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)						Applicants:			
						BEECHER et al.			
						Filing Date			
						May 25, 2000			
U.S. Patent Documents									
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date		
JE	AA	5,242,974	09/07/93	Holmes	525	54.11	Appropriate		
JE	AB	5,679,773	10/21/97	Holmes	530	334			
JE	AC	6,083,697	07/04/00	Beecher et al.	435	6			
	AD								
	AE								
	AF								
	AG								
	AH								
	AI								
	AJ								
	AK								
Foreign Patent Documents									
							Translation		
		Document	Date	Country	Class	Subclass	Yes	No	
	AL								
	AM								
	AN								
	AO								
	AP								
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)									
JE	AQ	MacDonald et al., "Chemical Amplification in High-Resolution Imaging Systems", Vol. 27, No. 6, June 1994, pps. 151-158.							
JE	AR	Willson, "Introduction to Microlithography", 2 nd Ed., ACS Professional Reference Book, 1994, pps. 212-233.							
	AS								
Examiner		Date Considered							
Jon E.		10/25/02							
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.									